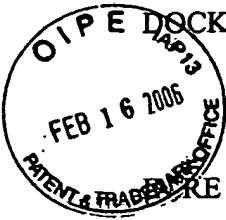


"RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 1763"



DOCKET NO: 245166US3CIP

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

PRE APPLICATION OF

TSUTOMU OKABE, ET AL.

SERIAL NO: 10/706,977

FILED: NOVEMBER 14, 2003

FOR: WAFER PROCESSING  
APPARATUS HAVING DUST PROOF  
FUNCTION

:

: EXAMINER: MOORE, K.

:

: GROUP ART UNIT: 1763

:

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated November 16, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.

Do NOT ENTER. 2/24/06 kw